SJSU SAN JOSÉ STATE UNIVERSITY

LUCAS COLLEGE AND GRADUATE SCHOOL OF BUSINESS

41ST ANNUAL HIGH TECHNOLOGY TAX INSTITUTE

November 3 & 4, 2025
Crowne Plaza Cabana Hotel
Co-sponsored by TEI and San Jose State University's College of Business

CE CREDIT SELF REPORTING FORM

	TOPIC	MINUTES AVAILABLE	MINUTES ATTENDED
Day 1	International High Technology U.S. Tax Current Developments	105	
Day 1	Breakout A – IP Development and Migration Tax Matters, or Breakout B – Corporate AMT	90	
Day 1	Keynote: Building a Relationship with the Board of Directors	55	
Day 1	R&D – Credits, Cases, TCJA.2, and More	90	
Day 1	Breakout C – Tax Issues of Doing Business in Brazil, or Breakout D – AI and Other Emerging Technologies for Tax Pros	90	
Day 2	Accounting for Income Taxes	60	
Day 2	Tariffs, Transfer Pricing, §1059A, Customs, Retaliation and More	75	
Day 2	The Latest and Greatest in M&A and Other Transactional Tax Developments	60	
Day 2	Keynote: DC Update	55	
Day 2	Breakout E – Pillar 2 Update, or Breakout F – Getting Your Head Out of the Clouds	75	
Day 2	Controversy and Guidance in a Constrained and Restricted Environment	90	
Day 2	Domestic and Multistate Tax Update	60	
	TOTAL MINUTES ATTENDED	905	

Method of Study: Live presentation

Subject Area: Technical (Tax)

SIGNATURE: ______________________________
Professor Annette Nellen, Director, TEI-SJSU High Tech Tax Institute

ATTENDEE NAME (PRINT) ______________________________

Company name: ______________________________

Please complete this CE sheet and retain it for your records. The CPA licensing rules of the state in which you are certified should be reviewed to determine how many hours of CPE were generated from the Institute (for example, 50 or 60 minute hours) and what records you must maintain and for how long, and whether any filing is required of you.

All attendees must have signed in each day to earn continuing education credits.